



BOX AF  
RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINER GROUP 2851

03560.002758

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

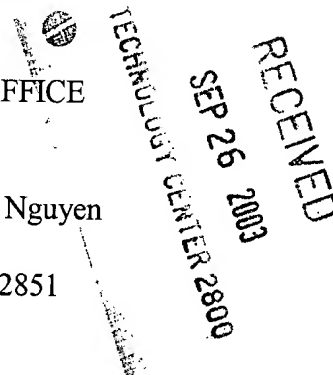
RYUICHI EBINUMA, ET AL.

Application No.: 09/817,018

Filed: March 27, 2001

For: SUPPORTING STRUCTURE OF OPTICAL  
ELEMENT, EXPOSURE APPARATUS  
HAVING THE SAME, AND MANUFACTURING)  
METHOD OF SEMICONDUCTOR DEVICE

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: Examiner: Hung Nguyen  
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: Group Art Unit: 2851  
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: September 22, 2003  
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**Mail Stop AF**  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

THIRD SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

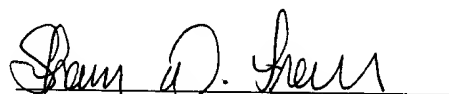
In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

Applicants requests that the above information be considered by the Examiner and that an initialed copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

This Information Disclosure Statement is being filed after the mailing of a first Official Action on the merits of the application. Accordingly, Applicants submit herewith the requisite fee of \$180.00 for consideration of the Information Disclosure Statement. The Commissioner is authorized to charge any deficiency in payment and/or credit any overpayment to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed for that purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

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SEW:SWF:eyw

DC-MAIN 142288 v1

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY DOCKET NO.  
**03560.002758**APPLICATION NO.  
**09/817,018**APPLICANT  
**RYUICHI EBINIUMA, ET AL.**FILING DATE  
**March 27, 2001**GROUP  
**2851**LIST OF REFERENCES CITED BY APPLICANT(S)  
(Use several sheets if necessary)

Submitted to the PTO September 22, 2003

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	<b>6,220,657</b>	<b>04/24/2001</b>	<b>Rea</b>	<b>296</b>	<b>220.01</b>	
	<b>6,295,118</b>	<b>09/25/2001</b>	<b>Takeuchi</b>	<b>355</b>	<b>52</b>	

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
<b>11-44834</b>	<b>02/16/1999</b>	<b>Japan</b>			<b>Abstract</b>
<b>11-231192</b>	<b>08/27/1999</b>	<b>Japan</b>			<b>Abstract</b>
<b>2001-242364</b>	<b>09/07/2001</b>	<b>Japan</b>			<b>Abstract</b>

## OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

SEW:SWF:eyw